



IPW

Docket No.: 65781-014

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Yoshihiko NEMOTO, et al.	:	Confirmation Number: 6548
Application No.: 10/629,695	:	Group Art Unit: 2813
Filed: July 30, 2003	:	Examiner: Smoot, Stephen W

For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH
PENETRATION ELECTRODES THAT PROTRUDE FROM A REAR SIDE OF A SUBSTRATE
FORMED BY THINNING THE SUBSTRATE (As Amended)

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action
dated August 5, 2004. Please amend the above-identified application as follows.